

#8/Ac-Amdt A  
DKing  
9/14/01



PATENT  
Customer No. 22,852  
Attorney Docket No. 08038.0032

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of: )  
)  
Takayuki NIUYA et al. ) Group Art Unit: 2812  
)  
Serial No.: 09/658,193 ) Examiner: Not yet assigned  
)  
Filed: September 8, 2000 )  
)  
For: METHOD OF MANUFACTURING )  
SEMICONDUCTOR DEVICE AND )  
MANUFACTURING APPARATUS )

Assistant Commissioner for Patents  
Washington, DC 20231

Sir:

**PRELIMINARY AMENDMENT**

Prior to the examination of the above application, please amend this application  
as follows:

**IN THE SPECIFICATION:**

Page 1, before line 5, insert:

--cross-reference to related application

This application is a Continuation of International Application No.

PCT/JP00/03544, filed June 1, 2000.--

Beginning on page 2 and continuing thru page 4, delete the entire section entitled

Disclosure of Invention and replace it with the following:

RECEIVED  
JUL 31 2001  
TO 2000 MAIL ROOM

A<sub>1</sub>

LAW OFFICES

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